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				Application Number	
				Filing Date	
				First Named Inventor	Manchao Xiao
				Art Unit	
				Examiner Name	
Sheet	1	of	3	Attorney Docket Number	06377ZP USA

U. S. PATENT DOCUMENTS					
Examiner Initials*	Cite No. ¹	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number-Kind Code ² (<i>If known</i>)			
		US- 6,350,708 B1	02/26/2002	Kelly T. Hurley	
		US- 6,204,206 B1	03/20/2001	Kelly T. Hurley	
		US- 6,127,287	10/03/2000	Kelly T. Hurley, et al	
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		US- 5,874,368	02/23/1999	Ravi K. Laxman	
		US-			

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Examiner Initials*	Cite No. ¹	Foreign Patent Document	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Country Code ³ Number ⁴ Kind Code ⁵ (<i>If known</i>)			
		JP 06132284(English abstract)	05/13/1994	Kawasaki Steel Corp	

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Sheet	2	of	3	Attorney Docket Number	06377ZP USA

NON PATENT LITERATURE DOCUMENTS			
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	
		G.E. MCGUIRE, Semiconductor Materials and Process Technology Handbook, Noyes Publication, 1988, pp. 289-301.	
		STANLEY WOLF, Silicon Processing for the VLSI Era, Lattice Press, 1990, Vol. II, pp. 20-22; 327-331.	
		TETSUJI SORITA, Mass Spectrometric and Kinetic Study of Low-Pressure.., J. Elect. Soc., 1994, Vol. 141, pp. 3505-3511.	
		B.A. SCOTT, Preparation of Silicon Nitride with Good Interface Properties.., Chemtronics, 1989, Vol. 4, pp. 231-234.	
		J.M. GROW, Growth Kinetics and Characterization of Low Pressure.., Elsevier Sci., 1995, Mat. Letters 23, pp. 187-193.	
		W.C. Yeh, Low-Temperature Chemical-Vapor-Deposition of Silicon-Nitride.., J. Appl. Phys., 1996, Vol. 35, pp. 1509-1512.	
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		ROY G. GORDON, Silicon Dimethylamido Complexes and Ammonia.., Chem. Mater. 1990, 2, pp. 480-482.	
		Z.I. SERGEEVA, Synthesis of Alkyl- and Dialkyl-Bis-(1,1-Dialkylhydrazino)-Silanes, J. Gen. Chem. of USSR, 1960, Vol. 30, pp. 716-717.	
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		MARCUS SOLDNER, Isomeric Cyclic Disilanediyi Dimethylhydrazines, Inorg. Chem., 1998, 37, pp. 601-603.	
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		DAVID R. LIDE, Handbook of Chem. and Physics, 81 st Edition, 2001, CRC Press, pp. 9-64-9-69.	
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